

Notice of References Cited	Application/Control No. 09/709,854	Applicant(s)/Patent Under Reexamination MARKEVITCH ET AL.	
	Examiner Paul D Kim	Art Unit 3729	Page 1 of 1

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	C	US-5,968,238	10-1999	Healy et al.	106/3
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.